Microelectronics	for the measurement Student: Solomon Ojo Major Professor(s): Dr. Fishe		UNIVERSITY OF ARKANSAS. Graduate School & International Education Microelectronics-Photonics Photonics
after, owing photonics w • GeSn/SiGeSu and quantur Innovation • Bandgap eng range of way • Explore nove access to co	elevance mance silicon-based lasers and detectors are sought to the possibility of monolithic integration of ith high-speed Si electronics. In offer design options from bulk to heterostructure in wells useful for the fabrication of a group IV laser. gineering for efficient light emission with wide velength coverage from near to Long-wave infrared. el growth techniques to reduce defects and gain impositions never grown before; high quality and esn alloys with high Sn content.	 Approach Epitaxial growth of high Sn composition of GeSn and SiGeSn using PEUHV-CVD. LED and laser devices fabrication. Investigate (Si)GeSn electrical and optical properties using Fourier-transform infrared spectroscopy (FTIR). Investigate structural parameters by transmission electron microscopy (TEM) and high resolution X-ray diffraction (HRXRD). Temperature-dependent PL spectroscopy in a cooled closed-cycle cryostat. 	fund the second
 Key Results Improved electrons an electrons	ectrically pumped GeSn lasers with high operating e towards RT. corporation with optimization of parameters for ancement technique diative recombination due to the localization of d holes in laser diode structures.	 Conclusions Electroluminescence lasing temperature up to 1 incorporation (World record). Improved carrier confinement by increasing SiGe reducing optical loss from the metal contact, and threshold. Development of a systematic method to explore growth condition to achieve higher quality and h composition. Future Work MQW development for future devices such as la photodetector should be further investigated. Research supported by AFOSR Laser (With SPG), FA9550- 	eSn cap thickness, d reduced the optimal higher Sn sers, LED, and

Fourier-transform infrared spectroscopy